

<b>Notice of References Cited</b>	Application/Control No. 10/524,058	Applicant(s)/Patent Under Reexamination TANAKA ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-4,519,020	05-1985	Little, William D.	362/268
*	D	US-4,151,584	04-1979	Labrum, Joseph H.	362/302
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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